



EV550719147

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/075,172
Confirmation No. 7318
Filing Date February 13, 2002
Inventor..... Brian E. Cron
Assignee..... Micron Technology, Inc.
Group Art Unit..... 3723
Examiner Eziamara Anthony Ojini
Attorney's Docket No. MI22-1804
Customer No. 021567
Title: Methods for Conditioning Surfaces of Polishing Pads After Chemical-Mechanical
Polishing

RESPONSE TO MAY 17, 2005 FINAL OFFICE ACTION

Response to Accompany an RCE Filing

To: Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS